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PATENT  
8017-1112

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Hidemitsu AOKI et al.

Conf. 8854

Application No. 10/717,715

Group 1751

Filed November 21, 2003

Examiner Brian P. Mruk

LIQUID COMPOSITION FOR CLEANING HYDROPHOBIC SUBSTRATE  
AND CLEANING METHOD THEREWITH

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the cited documents are made of record on the enclosed PTO Form-1449.

As the USPTO has waived the requirement under 37 CFR 1.98(a)(2)(i) for submitting a copy of each cited U.S. patent and patent publication for applications filed after June 30, 2003, a copy of the cited U.S. reference is not enclosed, as the present application is filed after June 30, 2003. Copies of the cited foreign patent documents and/or non-patent literature are enclosed.

A concise explanation of the relevance of these items is that these references were cited by the Japanese Patent Office in the corresponding Japanese Application Serial No. 2002-348204, filed November 29, 2002. A copy of the Japanese Official Action in which they were cited is attached hereto, with what is believed to be the pertinent portion

enclosed in a wavy line. **An English translation of the enclosed portion is also attached hereto.**

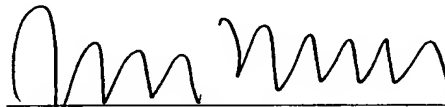
2005/0020463 is the U.S. equivalent of JP 2003-289060.

JP 11-116984 was cited in the Information Disclosure Statement filed November 21, 2003.

Under the provisions of 37 CFR 1.97(e), the undersigned hereby certifies that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing of this Statement.

Respectfully submitted,

YOUNG & THOMPSON



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<b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b> APR 04 2007 (Use several sheets if necessary) PATENT & TRADEMARK OFFICE	Attorney Docket No.: <b>8017-1112</b>	Application No.: <b>10/717,715</b>
	Applicant: <b>Hidemitsu AOKI et al.</b>	
	Filing Date: <b>November 21, 2003</b>	Group Art Unit: <b>1751</b>

## U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing date (if appropriate)
	2005/0020463	1/27/05	Ikemoto et al.			

## FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
	2003-289060	10/10/03	Japan				x
	2002-289569	10/4/02	Japan				X
	2002-79190	3/19/02	Japan				X
	2001-148385	5/29/01	Japan				x
	5-259140	10/8/93	Japan				x

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER:

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

\* Abstract provided for the Examiner's convenience